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## BIB DATA SHEET

CONFIRMATION NO. 7222

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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP04/03617 03/18/2004

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2003-077005 03/20/2003

## \*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\*

06/24/2006

Foreign Priority claimed 35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and /STEWART A FRASER/ Acknowledged _____ Examiner's Signature _____		Initials	JAPAN	3	16	2

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## TITLE

Substrate for reticle and method of manufacturing the substrate, and mask blank and method of manufacturing the mask blank

FILING FEE RECEIVED 1360	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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